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Title: A computational study of high-frequency behavior of graphene field-effect transistors

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Abstract:High Frequency potential of graphene field-effect transistors (FETs) is explored by quasi-static self-consistent ballistic and dissipative quantum transport simulations. The unity power gain frequency f<inf>MAX</inf> and the cut-off frequency f<inf>T</inf> are modeled at the ballistic limit and in the presence of inelastic phonon scattering for a gate length down to 5 nm. Our major results are (1) with a thin high-κ gate insulator, the intrinsic ballistic f<inf>T</inf> is above 5 THz at a gate length of 10 nm. (2) Inelastic phonon scattering in graphene FETs lowers both f<inf>T</inf> and f<inf>MAX</inf>, mostly due to decrease of the transconductance. (3) f <inf>MAX</inf> and f<inf>T</inf> are severely degraded in presence of source and drain contact resistance. (4) To achieve optimum extrinsic f<inf>MAX</inf> performance, careful choice of DC bias point and gate width is needed. © 2012 American Institute of Physics.

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Main heading:Graphene

Controlled terms: Ballistics - Field effect transistors - Phonon scattering - Quantum electronics

Uncontrolled terms:Ballistic Limit - Computational studies - DC bias - Gate insulator - Gate length - Gate widths - High frequency - High frequency HF - Power gain frequency - Quantum transport simulations - Quasi-static - Source and drains

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